## What is claimed is:

- 1. A near field microscope comprising:
- a wave source, which emits a wave with a variable frequency;
- a waveguide resonator through which the wave emitted from the wave source propagates;

a probe, which perforates an outer wall of the waveguide resonator and by which the wave that propagates through the waveguide resonator interacts with a sample; and

a detector, which detects the wave that has interacted with the sample.

2. The near field microscope of claim 1, further comprising a tuner, which is movably connected to one end of the waveguide resonator and adjusts a length of the waveguide resonator.

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- 3. The near field microscope of claim 1, wherein a portion of the probe inside the waveguide resonator has a linear shape.
- 4. The near field microscope of claim 1, wherein a portion of the probe inside the waveguide resonator has a loop shape.
  - 5. The near field microscope of claim 1, wherein a probe portion outside the waveguide resonator has a linear shape or a loop shape.
  - 6. The near field microscope of claim 1, wherein the probe is formed of metal, a dielectric material, or a magnetic substance.
    - 7. The near field microscope of claim 4, wherein when  $H_0$  is a maximum value of a magnetic field perforating the portion of the probe inside the waveguide resonator,  $\mathbf{p}$  is a p-value in a  $TE_{10P}$  mode,  $z_i$  is a position of a front end of the portion of the probe inside the waveguide resonator,  $z_f$  is the position of a rear end of the portion of the probe inside the waveguide resonator and  $\mathbf{d}$  is a length of

the waveguide resonator, a magnitude of an electromotive force generated in the probe is given by:

$$V = -\frac{\mu_0 j \omega a y H_0}{\pi} [2 \cos \frac{1}{2} \{ \frac{p \pi}{d} (z_f + z_i) \} \sin \frac{1}{2} \{ \frac{p \pi}{d} (z_f - z_i) \} ].$$

8. The near field microscope of claim 7, wherein the probe is disposed in a position that satisfies  $z_i=3d/2p$ ,  $z_i=d/2p$ .

- 9. The near field microscope of claim 5, wherein a slit is formed in the waveguide resonator, and the probe is movable along the slit.
  - 10. The near field microscope of claim 1, wherein when a width of a cross-section of the waveguide resonator is **a**, a height of the waveguide resonator is **b**, and **m** and **n** are integers, a cut-off frequency f<sub>cmn</sub> of the waveguide resonator is given by:

$$f_{cmn} = \frac{1}{2\pi\sqrt{\mu\varepsilon}}\sqrt{\left(\frac{m\pi}{a}\right)^2 + \left(\frac{n\pi}{b}\right)^2},$$

and a wave with a frequency greater than the cut-off frequency is used.

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11. The near field microscope of claim 1, wherein, when a resonance frequency and a volume before the probe is inserted into the waveguide resonator are  $f_0$  and  $v_0$ , respectively, and a change in volume of the probe after the probe is inserted into the waveguide resonator is  $\Delta v$ , a change in resonance frequency f of the waveguide resonator is given by:

$$\frac{f-f_0}{f_0} = -\frac{2\Delta v}{v_0}.$$

12. The near field microscope of claim 1, wherein the probe is a hybrid probe manufactured using partial two-step etching.

- 13. The near field microscope of claim 1, further comprising a lock-in amplifier, which minimizes noise by improving a signal-to-noise ratio between the wave source and the waveguide resonator.
- 14. The near field microscope of claim 1, wherein the wave source emits microwaves or millimeter-waves.
- 15. The near field microscope of claim 1, wherein when a wavelength of the wave emitted from the wave source is  $\lambda$ , the length of the waveguide resonator changes by  $\lambda$  /4 increments.
  - 16. The near field microscope of claim 4, wherein the probe portion having the loop shape is disposed parallel to an advancing direction of the wave.

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